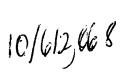
Refine Search



Search Results -

Terms	Documents	
L1 and (oxygen adj atoms)	11	

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Set Name side by side	Query	<u>Hit</u> Count	Set Name result set
DB=U	SPT; PLUR=YES; OP=ADJ		
<u>L2</u>	L1 and (oxygen adj atoms)	11	<u>L2</u>
<u>L1</u>	(silicon adj oxide) and (silicon adj nitride) and (antireflection near4 film)	156	<u>L1</u>

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Search Results - Record(s) 1 through 10 of 11 returned.

1. Document ID: US 6607986 B2

L2: Entry 1 of 11

File: USPT

Aug 19, 2003

US-PAT-NO: 6607986

DOCUMENT-IDENTIFIER: US 6607986 B2

** See image for Certificate of Correction **

TITLE: Dry etching method and semiconductor device manufacturing method

Full Title Citation Front Review Classification Date Reference Claims KMC Draw De 2 Document ID: US 6417083 B1 Jul 9, 2002

File: USPT

US-PAT-NO: 6417083

L2: Entry 2 of 11

DOCUMENT-IDENTIFIER: US 6417083 B1

TITLE: Methods for manufacturing semiconductor devices

Claims RMC Draw De Full Title Citation Front Review Classification Date Reference 3. Document ID: US 6350397 B1

L2: Entry 3 of 11

File: USPT

Feb 26, 2002

US-PAT-NO: 6350397

DOCUMENT-IDENTIFIER: US 6350397 B1

TITLE: Optical member with layer having a coating geometry and composition that

enhance cleaning properties

Full Title Citation Front Review Classification Date Reference Claims KMC Draw.09

4. Document ID: US 6297114 B1

L2: Entry 4 of 11

File: USPT

Oct 2, 2001

US-PAT-NO: 6297114

. Record List Display Page 2 of 3

DOCUMENT-IDENTIFIER: US 6297114 B1

TITLE: Semiconductor device and process and apparatus of fabricating the same

Full Title Citation Front Review Classification Date Reference Communication Draw Do

5. Document ID: US 6270948 B1

L2: Entry 5 of 11

File: USPT

Aug 7, 2001

US-PAT-NO: 6270948

DOCUMENT-IDENTIFIER: US 6270948 B1

** See image for Certificate of Correction **

TITLE: Method of forming pattern

Full Title Citation Front Review Classification Date Reference Claims NWC Fram Do

US-PAT-NO: 5976684

DOCUMENT-IDENTIFIER: US 5976684 A

TITLE: Organic substrate provided with a light absorptive antireflection film and

process for its production

Full Title Citation Front Review Classification Date Reference Claims KWC Draw Draw 7. Document ID: US 5897377 A

7. Document 1D. OS 3097

L2: Entry 7 of 11

File: USPT

Apr 27, 1999

US-PAT-NO: 5897377

DOCUMENT-IDENTIFIER: US 5897377 A

TITLE: Semiconductor device manufacturing method with use of gas including acyl-

group-containing compound

Full Title Chation Front Review Classification Date Reference Claims RMC Draw D:

8. Document ID: US 5803975 A

L2: Entry 8 of 11

File: USPT

Sep 8, 1998

US-PAT-NO: 5803975

DOCUMENT-IDENTIFIER: US 5803975 A

** See image for <u>Certificate of Correction</u> **

TITLE: Microwave plasma processing apparatus and method therefor

	Title Citation Front Review	ii Classification Date Reference		Claims KWC Draw
	9. Document ID: US 5 Entry 9 of 11	730922 A File: USPT		Mar 24, 1998
JS-PAT-N	O: 5730922 -IDENTIFIER: US 5730	9922 A		·
		g process for composite	s	
Full	Title Citation Front Review	n Classification Date Reference		Claims KMC Craw
****	10. Document ID: US Entry 10 of 11	5409777 A File: USPT		Apr 25, 1995
	•			• ,
JS-PAT-N OCUMENT	O: 5409777 -IDENTIFIER: US 5409 mage for <u>Certificate</u>	9777 A		• ,
JS-PAT-N OCUMENT ** See i	O: 5409777 -IDENTIFIER: US 5409 mage for <u>Certificate</u>	9777 A	utane rings	• ,
JS-PAT-N DOCUMENT ** See i	O: 5409777 -IDENTIFIER: US 5409 mage for <u>Certificate</u> aminates of polymer	9777 A e of Correction **	utane rings	Claims KWC Draw
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JS-PAT-N DOCUMENT ** See i FITLE: L	O: 5409777 -IDENTIFIER: US 5409 mage for <u>Certificate</u> aminates of polymer	9777 A e of Correction ** shaving perfluorocyclob Glassfication Cate Reference	1	Glaims Nuit Dian

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Search Results - Record(s) 11 through 11 of 11 returned.

11. Document ID: US 5246782 A

L2: Entry 11 of 11

File: USPT

Sep 21, 1993

US-PAT-NO: 5246782

DOCUMENT-IDENTIFIER: US 5246782 A

TITLE: Laminates of polymers having perfluorocyclobutane rings and polymers

containing perfluorocyclobutane rings

30	itle Citation Front Review Classification Date Refe	ence Claims	KWIC Draw D
Clear	Generate Collection Print Fwd R	tefs Bkwd Refs Gener	ate OACS
	Terms	Documents	
	L1 and (oxygen adj atoms)		<u>1 1</u>]

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